

Session Program

Jul 2 – 6, 2018

EPS 2018 Programme

LTDP

Žofín Palace
Slovanský ostrov 226, 110 00 Praha 1

Tue, July 3

10:40 AM

LTDP

Session | Location: Mánes Bar | Convener: H. Thomas

10:40 – 11:10 AM

I2.305 Influence of plasma pulsing on active species kinetics in low pressure radiofrequency ICP plasmas

Speaker

Agnes Granier

11:10 – 11:40 AM

I2.306 Extraction of positive and negative ion beams from large area plasma sources

Speaker

Svetlana Radovanov

11:40 – 11:55 AM

O2.301 Design and performance of solid-state microwave plasma sources for lab and industrial applications

Speaker

Kostiantyn Achkasov

11:55 AM – 12:10 PM

O2.302 Current Status of Etching Process Diagnostics and Simulations Based on Atomic and Molecular Data

Speaker

Jung-Sik Yoon

12:10 – 12:25 PM

O2.303 Glow Discharges with Gridded Electrodes: Models and Applications

Speaker

Stepan Eliseev

12:25 – 12:40 PM

O2.304 Features of forming atmospheric pressure plasma jet in helium and argon flows

Speaker

Olga Stepanova

12:40 PM